

Transaction Information

ToolId	TP-WNW-01 (Chmx1)
ToolStatus	Warehouse
Location	Singapore
WaferSize	300 mm
FabSection	Thin Film

General Product Information

VendorSupplier	AMAT
Model	Endura 2 (Chambers only)
Vintage	2006
SerialNo	Main tool(407758)
AssetDescription	
SoftwareVersion	
CIM	
Process	Ti Dep

Hardware Configuration (Fab)

SystemType	Description	Quantity	Status
Main System	Chamber 1	1	
Factory Interface	NONE		
Handler System	na		
Options System			
Others			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
NONE		

Missing/Faulty Parts / Accesories List

Description	Quantity
NONE	

Tool Pictures

general

Chamber picture



Additional Configuration Files

	Process:	Ti Dep	
	Equipment ID	TP-WNW-01 (Chamber 1)	
	Model	ENDURA II	
C1	C1	DSTTN	
	Source Target	Ti	
	Gas panel detail		
	Ar1	100sccm	UFC8565C
	Ar2	200Sccm	UFC8565C
	RGA Valve	Manual	MKS
	Source type	STD DC SRC	
	SRC PWR Supply		
	DUAL DC PWR SPLY		
	Bias type	NA	NA
	BIAS PWR SPLY	NA	NA
	BIAS RF MATCH	NA	NA
	RF Coil PWR SPLY	NA	NA
	RF Coil Match	NA	NA
	Pedestal	A101	None grounded
	Lifter type		Stepper heater, Stepper pins
	Shutter	Motorized shutter	
	Cryo pump type	CTI onboard	
	Cryo pump	OB IS-8F CTI onboard	CTI Cryogenics
	Pumps, Rough	Shared with System	
	Controller	CCT Tower	